PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Tokyo Seimitsu Co., Ltd.	12/20/2006

RECEIVING PARTY DATA

Name:	Super Silicon Crystal Research Institute Corp.	
Street Address:	Seavans N, 2-1, Shibaura 1-chome,	
Internal Address:	Minato-ku	
City:	Tokyo	
State/Country:	JAPAN	

PROPERTY NUMBERS Total: 1

Property Type	Number
Patent Number:	6178961

CORRESPONDENCE DATA

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ATTORNEY DOCKET NUMBER:	740107-116(DSS)
NAME OF SUBMITTER:	David S. Safran

Total Attachments: 1

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PATENT REEL: 018787 FRAME: 0852

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ASSIGNMENT

For good and valuable consideration, the sufficiency and receipt of which is hereby acknowledged, as owner of record of an undivided one-half interest in U.S. Patent No. 6,178,961 issued January 30, 2001 by assignment recorded at Reel 010680, Frames 0342-4, Tokyo Seimitsu Co., Ltd., hereby sells and assigns to Super Silicon Crystal Research Institute Corp. of Seavans N, 2-1, Shibaura 1-chome, Minato-ku, Tokyo, Japan, all of its rights, title and interest in said Letters Patent, the said interest being its half ownership of the said Letters Patent, to be held and enjoyed by said Super Silivon Crystal Reasearch Institute Corp., its successors, assigns or other legal representatives, to the full end of the term for which said Letters Patent may be granted, as fully and entirely as the same would have been held and enjoyed by Tokyo Seimitsu Co., Ltd. if this assignment and sale had not been made.

Tokyo Seimitsu Co., Ltd.

7000 37

Title: Executive Vice President

Date: December 20, 2006

RECORDED: 01/23/2007

PATENT REEL: 018787 FRAME: 0853